Attorney's Docket No.: 07977-280001 / US5027

D STATES PATENT AND TRADEMARK OFFICE

Applicant: Shunpei Yamazaki et al

Art Unit : 2825

Serial No.: 09/894,950

Examiner: Caridad Everhart

Filed

: June 27, 2001

Confirmation No.: 6263

Title

: SEMICONDUCTOR DEVICE AND MANUFACTURING METHOD THEREOF

MAIL STOP AMENDMENT

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Applicants would like to bring the Examiner's attention to the references listed on the attached form PTO-1449. It is respectfully requested each of the references listed on the attached form PTO-1449 be considered by the Examiner and that the document be initialed and returned to the undersigned.

This statement is being filed after a first Office action on the merits, but before receipt of a final Office action or a Notice of Allowance. A check for \$180 in payment of the late submission fee of C.F.R. § 1.17(p) is enclosed. Please apply any other charges or credits to Deposit Account No. 06-1050.

Respectfully submitted,

Date: January 19, 2005

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Substitute Form PTO-1449 (Modified)	U.S. Department of Commerce Patent and Trademark Office	Attorney's Docket No. 07977-280001	Application No. 09/894,950
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(Use several si	heets if necessary) 9 2005	Filing Date June 27, 2001	Group Art Unit

tion Patent Documents							
Examiner Initial	Desig. ID	Document Number	Publication Date	Patentee	Class	Subclass	Filing Date If Appropriate
	AA	5,079,606	01/07/1992	Yamamura et al.	_		01/19/1990
	AB	5,605,847	02/25/1997	Zhang			06/02/1995
	AC	5,643,801	07/01/1997	Ishihara et al.			08/04/1995
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	AF	6,243,155 B1	06/05/2001	Zhang et al.			10/19/1998
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	AH	6,462,806 B2	10/08/2002	Zhang et al.			12/29/2000
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	AK	6,638,800 B1	10/28/2003	Ishihara et al.			10/01/1999
	AL	6,740,938 B2	05/25/2004	Tsunoda et al.			04/10/2002

	Foreign Patent Documents or Published Foreign Patent Applications							
Examiner	Desig.	Document	Publication	Country or			Trans	slation
Initial	ID	Number	Date	Patent Office	Class	Subclass	Yes	No
	AM							
	AN							
	AO							
	AP							
	AQ							

	Other Documents (include Author, Title, Date, and Place of Publication)					
Examiner Initial	Desig. ID	Document				
	AR					
	AS					
,	AT					
	AU					

idered						
EXAMINER: Initials citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with						
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